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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/603,019	06/24/2003	Shunpei Yamazaki	740756-2626	3291	
22204	7590 04/27/2004		EXAMINER		
NIXON PEABODY, LLP 401 9TH STREET, NW			LE, DUNG ANH		
SUITE 900		ART UNIT	PAPER NUMBER		
WASINGTON, DC 20004-2128			2818		
			DATE MAILED AMERICA	DATEMAN ED 04/27/2004	

DATE MAILED: 04/27/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
Office Antique Communication	10/603,019	YAMAZAKI ET AL.				
Office Action Summary	Examiner	Art Unit				
	DUNG A LE	2818				
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	6(a). In no event, however, may a reply be tim within the statutory minimum of thirty (30) days ill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONEI	rely filed s will be considered timely. the mailing date of this communication. O (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on						
a) ☐ This action is <b>FINAL</b> . 2b) ☐ This action is non-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims						
4) Claim(s) <u>1-3</u> is/are pending in the application.						
4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.						
6) Claim(s) is/are rejected.						
, , , , , , , , , , , , , , , , , , , ,	7) Claim(s) 1-3 is/are objected to.					
8) Claim(s) are subject to restriction and/or	election requirement.					
Application Papers						
9) The specification is objected to by the Examiner.						
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).						
11)☐ The oath or declaration is objected to by the Ex	aminer. Note the attached Office	Action or form PTO-152.				
Priority under 35 U.S.C. § 119						
<ul> <li>12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:</li> <li>1. Certified copies of the priority documents</li> <li>2. Certified copies of the priority documents</li> <li>3. Copies of the certified copies of the priority application from the International Bureau</li> <li>* See the attached detailed Office action for a list</li> </ul>	s have been received. s have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)).	on No. <u>09/493,411</u> . ed in this National Stage				
		× ,				
Attachment(s)  1) Notice of References Cited (PTO-892)  4) Interview Summary (PTO-413)						
1) X Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail D	ate				
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 6/24/2003.	5)  Notice of Informal F 6)  Other:	Patent Application (PTO-152)				

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#### **DETAIL ACTION**

## **Priority**

Acknowledge is made of applicants' claim for foreign priority base on an application 11-022298 filed in Japan on 01/19/1999

It is noted that Applicants have not filled a certified copy of said application as required by U.S.C 119. The certified priority document was filed in the co-pending application/Patent Serial Number 09/493411 on 01/28/2000.

### Oath/Declaration

The oath/declaration filed on 6/24/2003 is acceptable.

# Information Disclosure Statement

This office acknowledges of the following items from the Applicant:

Information Disclosure Statement (IDS) filed on 6/24/2003 and made of record The references cited on the PTOL 1449 form have been considered.

This application is in condition for allowance except for the following formal matters:

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The specification is objected to for the following reasons

i): The title of the invention is not descriptive. A new title is required that is clearly indicative of the invention to which the claims are directed (see MPEP § 606.01).

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ii) A new abstract is required that is clearly indicative the invention to which the claims are directed.

Note that, the claims are directed to a method of making a semiconductor device instead of to a semiconductor device.

The specification has been checked to the extent necessary to determine the presence of all possible minor errors. However, the applicant's cooperation is requested in correcting any errors of which applicant may become aware in the specification.

iii) After Title, please enter -- CROSS REFERENCE TO A RELATED PATENT.

The subject matter of the present application is a divisional of application 09/493411 now an U. S Patent No. 6,593,592. --

#### Reasons for Indication of Allowable Subject Matter

Claims 1-3 would be allowed. The following is an examiner's statement of reason for allowance:

None of the references of record teaches or suggests the claimed Semiconductor device having the steps of forming a gate wiring and second capacitance electrode over the insulating film containing silicon and the first insulating film and exposing a portion of the second

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capacitance electrode by removing a part of the first interlayer insulating film and among other steps as cited in independent claim.

Prosecution on the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

A shortened statutory period for reply to this action is set to expire **TWO**MONTHS from the mailing date of this letter.

When responding to the office action, Applicants' are advice to provide the examiner with the line numbers and page numbers in the application and/or references cited to assist the examiner to locate the appropriate paragraphs.

### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Dung A. Le whose telephone number is (571) 272-1784. The examiner can normally be reached on Monday-Friday 8:00am-5: 30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 872-9306 for regular communications and (703) 872-9306 for After Final communications.

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Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Dung A. Le

P. Examiner.